

2623  
TFW**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Application of: :  
Christopher L. Wooten, et al. : Group Art Unit: 2623  
Application No.: 09/976,739 : Examiner: Wesley J. Tucker  
Filed: October 11, 2001 :

Title: METHOD FOR PERFORMING DEFECT SPATIAL SIGNATURE ANALYSIS IN A  
SEMICONDUCTOR MANUFACTURING PROCESS

Mail Stop Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

**AMENDMENT TRANSMITTAL**

- Transmitted herewith is an Amendment for this application.
- The fee for claims has been calculated as follows:

CLAIMS AS AMENDED									
	Claims After Amendment		No. Prev. Paid For		Present Extra		Rate - Small		Add'l Fee
Total	20	-	20	=	0	x	\$50.00	=	0.00
Indep.	3	-	3	=	0	x	\$200.00	=	0.00
Filing Fee Calculation:									<u>\$0.00</u>

- The total fees to be paid are as follows and are enclosed payable to the

Commissioner of Patents and Trademarks:

Fee for claims adjustment: 0.00  
Extension fee: 0.00  
Total Fees Due: \$0.00

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**Amendment Transmittal**

4. Applicant believes there are no additional fees required for these filings. The Commissioner is hereby authorized to charge any deficiency to Deposit Account No. 50-2173.

Respectfully submitted,

Dated: 7 February 2006

By Rennie W. Dover

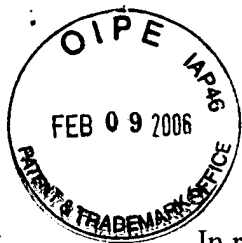
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CERTIFICATE OF MAILING UNDER 37 C.F.R. § 1.8

I hereby certify that this document (and any as referred to as being attached or enclosed) is being deposited with sufficient postage as first class mail with the United States Postal Service on February 7, 2006 and addressed to Mail Stop Amendment, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

I hereby declare that all statements made herein of my own knowledge are true and that all statements made on information and belief are believed to be true; and further that these statements were made with the knowledge that willful false statements and the like so made are punishable by fine or imprisonment, or both, under Section 1001 of Title 18 of the United States Code, and that such willful false statements may jeopardize the validity of the application or any patent issued thereon.

Allen T. Brown



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**AMENDMENT**

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Madam/Sir:

In response to the Office action mailed November 7, 2005, please amend the  
application as follows: